

ATMI-521  
Serial No. 09/929,564**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re United States Patent Application of: )  
)  
Applicants: Ying Ma et al. )  
)  
Serial No.: 09/929,564 )  
)  
Date Filed: August 14, 2001 )  
)  
Title: Improved Chemical Mechanical )  
Polishing Compositions for Metal )  
and Associated Materials and )  
Method of Using Same )

Docket No.: ATMI-521

Examiner: Eileen P. Morgan

Art Unit: 3723

Customer No.: 25559

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Maggie ChappuisFebruary 13, 2004  
Date of Transmission(703) 872-9306  
Facsimile Number**RESPONSE AUGUST 14, 2003 OFFICE ACTION IN  
U.S. PATENT APPLICATION 09/929,564 AND  
PETITION FOR THREE MONTH EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 14, 2003, applicant respectfully requests entry of the following Amendments and consideration of the subsequent remarks.